IN THE UNITED STATES PATENT AND TRADEMARK OFFICE ALEXANDRIA, VA 22313-1450

Appl No.: 10/758,132
Applicant: Jeng et al.
Filing Date: 1/16/2004
Art Unit: 2812

Examiner: Richard Booth

Attorney Docket No.: Richard Boo

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INTERVIEW SUMMARY AND AMENDMENT

Dear Sir:

The applicant hereby thank the examiners for the personl interview conducted on March 6, 2007. The applicant hereby files written statement of the reasons presented at the March 6, 2007 personal interview as warranting favorable action.

Halliyal reference was discussed in detail, and Primary Examiner Richard Booth made the determination that the claims as proposed read over the Halliyal reference, as Halliyal reference does not disclose inplanting hetero element on the top layer of the gate dielectric layers so as to provide an increased electron trapping density in the gate dielectric layers.

Claims presented are reflected in the listing of claims which begins on page 2 of this paper.

Specification are amended to correct grammatical errors on page 4 of this paper.